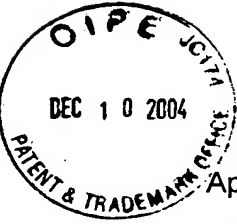


IPW

500.40633VX1



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: H. Kitsunai, et al.  
Application No.: 10/825,114  
Filed: April 16, 2004  
For: PROCESS FOR PRODUCING SEMICONDUCTOR DEVICE  
Group: 1763  
Examiner: P. Hassanzadeh

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 10, 2004

Sir:

In response to the Office Action mailed September 10, 2004, please amend the above-identified application as listed in the following, and as set forth on the following pages:

Amendments to the Specification;

Amendments to the Claims; and

Remarks are included following the amendments.